

U.S. Department of Commerce, Patent and Trademark Office		Docket No.	Serial No.
		CCBI/0010	10/616,014
LIST OF RELEVANT ART CITED BY APPLICANT (Use several sheets if necessary)		Applicant	
		John K. Lewis	
		Filing Date	Group
		July 9, 2003	3679



## U.S. Patent Documents

*Examiner Initial		Document Number	Issue Date	Name	Class	Subclass	Filing Date If Appropriate
OK	A	3,863,328 A	Feb. 4, 1975	Arntz			
	B	4,125,924 A	Nov. 28, 1978	Goetze			
	C	4,784,311 A	Nov. 15, 1988	Sugao			
DS	D	6,536,806 B1	Mar. 25, 2003	Uematsu, et al			

## Foreign Patent Documents

## Translation

		Document Number	Date	Country	Class	Subclass	Yes	No
DS	E	EP 0 103 439 B	Mar. 3, 1984	Europe				

## OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

F	Partial International Search Report; International Filing Date July 7, 8, 2004; International Application No. PCT/US2004/021811; 3 pages

Examiner David Bl Date Considered 9/13/05

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DK3	2003/0094209 A1	May 22, 2003	Katsuhiro Imasaki, et al.			
	831,887	Sept. 25, 1906	John H. Nicholson			
	2,371,348	Mar. 13, 1945	M. G. Murray			
	3,397,445	Aug. 20, 1968	W. L. Ulmer, et al.			
	3,481,024	Dec. 2, 1969	E. S. Bunn			
	3,604,102	Sept. 14, 1971	Mario Boccalari, et al.			
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	4,049,184	Sept. 20, 1977	Jury Iosifovich Rozengart, et al.			
	4,125,924	Nov. 21, 1978	Edward S. Goetze, et al.			
	4,162,758	July 31, 1979	Makoto Mikarai			
	4,319,121	Mar. 9, 1982	Toshio Yoshida			
	4,367,838	Jan. 11, 1983	Toshio Yoshida			
	4,470,188	Sep. 11, 1984	Richard L. Holbrook, etc.			
	4,533,806	Aug. 6, 1985	Tatsuo Kawasaki, et al.			
DK3	4,765,529	Aug. 23, 1988	William C. Turner			

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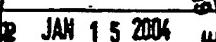
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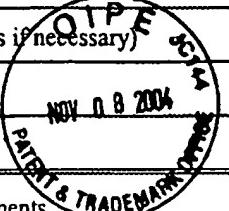
**OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)**

	CC	"Use of new technology in Bintang gas development project"; PETROMIN May/June 2003; pages 14-16.
	DD	"Butting Produkt – Butting Bimetal Pipes; <a href="http://www.butting.de">www.butting.de</a> ; BUTTING GmbH & Co. KG; 6 pages.

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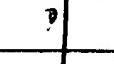
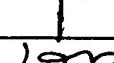
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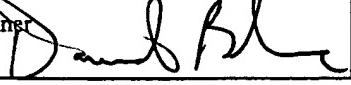
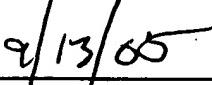
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	A	"TFP & TFT Metal Lined Pipe & Tubing"; Internet brochure of Kuroki Tube and Pipe Co., LTD.; pgs. 1 - 8.
	B	"Clad Line Pipe for Oil & Gas Fields"; Sumitomo Metal Industries, LTD.; No. 14421/Printed in Japan by New Market Inc./2; 7 pages.
	C	3 G Position Welding by DPS-CII GTAW Process; 1 page.
	D	"Where Toughness Counts Most, High Nickel-Clad Welded Pipe with Superior Anti-Corrosion Properties"; 1 page; NKK Corporation, Tokyo, Japan.
	E	"C-II ---For New Transportation System; Nippon Steel; 4 pages.
	F	"Butting - Bimetal Corrosion Resistant Pipes"; The Website for the Chemicals Industry; 2 pages.

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